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<b>** CONTINUING DATA *****</b> None. EP				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-224254 07/31/2002 verified. EP JAPAN 2003-97210 03/31/2003				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 10/23/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <i>[Signature]</i> EP Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 104	TOTAL CLAIMS 53  INDEPENDENT CLAIMS 19
<b>ADDRESS</b> 020457				
<b>TITLE</b> Semiconductor memory device and a method of manufacturing the same, a method of manufacturing a vertical MISFET and a vertical MISFET, and a method of manufacturing a semiconductor device and a semiconductor device				
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